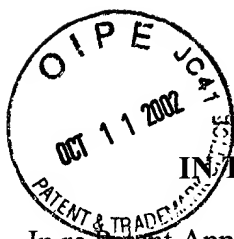


2814



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji TAKEDA et al. ✓

Serial No. 09/785,194 ✓

Filed: February 20, 2001 ✓

For: SEMICONDUCTOR DEVICE AND
PROCESS FOR FABRICATION
THEREOF

)
) Atty. Docket No.: TM&K0006
)
) Group Art Unit: 2814
)
) Examiner: GRAYBILL, D.
)
)
) Date: October 11, 2002
)
)

#16
Response
J. Mancilla
10/17/02
RECEIVED
OCT 16 2002
TECHNOLOGY CENTER 28000

SUPPLEMENTAL RESPONSE TO AMENDMENT (B)

Box: No Fee Amendment

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the official Office Action dated December 26, 2001, and in response to the official Office Communication dated September 16, 2002, Applicants provide the following additional remarks.

REMARKS

Applicant responds below to the Examiner's request for information under 37 C.F.R.

1.105, being directed to identification of what is being improved (Office Action, dated December 26, 2001, page 7, lines 3-12). Applicant also provides additional remarks showing how the Declaration filed under 37 C.F.R. 1.132 by Takashi Masuko (hereafter, the "Masuko Declaration") provides evidence of superior and unexpected results that are commensurate in scope with the claims.

The following additional remarks are to be considered along with Applicants' Amendment (B) filed on June 25, 2002, which is incorporated herein by reference.